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PTO/SB/08B (08-03)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known	
		Application Number	10/532,907
		Filing Date	April 27, 2005
		First Named Inventor	Nathan T. Hayes
		Art Unit	N/A
		Examiner Name	N/A
Sheet 2	of 3	Attorney Docket Number	33072/101/101

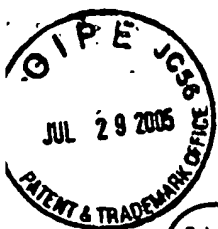
NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Kw		ANDREW S. GLASSNER, "An Introduction to Ray Tracing", Academic Press, 1993	
		HELMUT RATSCHKE & JON ROKNE, "SCCI-Hybrid Methods for 2D Curve Tracing", International Journal of Image and Graphics, Vol. 5, No. 3 (2005) p.447-479	
		HEIDRICH, WOLFGANG, PHILIPP SLUSALLEK & HANS-PETER SEIDEL, "Sampling Procedural Shaders Using Affine Arithmetic." ACM Transactions on Graphics 17.3 (Jul. 1998): 158-176.	
		SUNG, KELVIN, ANDREW PERACE & CHANGYAW WANG, "Spatial-Temporal Antialiasing." IEEE Transactions on Visualization and Computer Graphics 8.2 (Apr.- Jun. 2002): 144-153.	
		ENGER, WOLFGANG, "Interval Ray Tracing - a divide and conquer strategy for realistic computer graphics." The Visual Computer 9.2 (1992): 91-104.	
		DUFF, TOM, "Interval Arithmetic and Recursive Subdivision for Implicit and Constructive Solid Geometry." Computer Graphics 26.2 (Jul. 1992): 131-138.	
		DE CUSATIS JUNIOR, DE FIGUEIREDO, & GATTASS, "Interval Methods for Ray Casting Implicit Surfaces with Affine Arithmetic", Department of Computer Science & LNCC-Laboratorio Nacional de Computacao Cientifica	
		CAPRANI, OLE, ET AL. "Robust and Efficient Ray Intersection of Implicit Surfaces." Reliable Computing 6.1 (Feb. 2000): 9-21.	
		ALEXANDRE MEYER & EMMANUEL CECCHET, "Stingray: Cone tracing using a software DSM for SCI clusters", iMAGIS - GRAVIR/IMAG-SIRAC, France	
Kw		AMANATIDES, JOHN. "Ray Tracing with Cones." Computer Graphics 18.3 (Jul. 1984): 129-135.	

Examiner Signature	<i>Kronborg</i>	Date Considered	11-10-06
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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<i>kw</i>		LUIZ HENRIQUE DE FIGUEIREDO, "Surface Intersection Using Affine Arithmetic", Computer Systems Group, Department of Computer Science, University of Waterloo	
		QUINN O. SNELL, "Parallel hierarchical global illumination", Major Professor: John L. Gustafson Iowa State University, p. 1-77	
		EUGENE A. MORELLI, "Global Nonlinear Parametric Modeling with Application to F-16 Aerodynamics", Dynamics and Control Branch, NASA Langley Research Center, Hampton, Virginia, p. 1-5	
		COMBA & STOLFI, "Affine Arithmetic and its Applications to Computer Graphics", Computer Graphics Laboratory & Computer Science Department, p. 1-10, 1993	
		GENETTI, GORDON & WILLIAMS, "Adaptive Supersampling in Object Space Using Pyramidal Rays" Computer Graphics forum, Volume 17 (1998), number 1 pp. 29-54	
		HAEBERLI, PAUL & KURT AKELEY. "The Accumulation Buffer: Hardware Support for High-Quality Rendering." Computer Graphics 24.4 (Aug. 1990): 309-318.	
		BLINN, JIM. "Jim Blinn's Corner: Notation, Notation, Notation." Morgan Kaufmann, 2002.	
		DUTRE, PHILIP, PHILIPPE BEKAERT & KAVITA BALA. "Advanced Global Illumination." AK Peters, 2003.	
		JAULIN, LUC, ET AL. "Applied Interval Analysis." Springer Verlag, 2001.	
<i>kw</i>		APODACA, ANTHONY & LARRY GRITZ. "Advanced RenderMan: Creating CGI for Motion Pictures." Morgan Kaufmann, 1999.	

Examiner Signature	<i>Jonathan Nguyen</i>	Date Considered	11-10-06
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